


<b>Search Notes</b>  	<b>Application/Control No.</b>  10666309	<b>Applicant(s)/Patent Under Reexamination</b>  CREAMER ET AL.
	<b>Examiner</b>  Park, Jeong S	<b>Art Unit</b>  2109

SEARCHED			
Class	Subclass	Date	Examiner
709	224	4/2/2007	Jeong Park

SEARCH NOTES		
Search Notes	Date	Examiner
limited text search of 709/224 with terms of "monitoring or monitored", "system", "behavior or pattern", "web"	4/2/2007	Jeong Park
limited text search of 709/224 with terms of "monitoring or monitored", "system", "behavior", "multiple or plurality"	4/5/2007	Jeong Park
Text search with terms of "computing resource", "web server"	9/6/2007	Jeong Park
Text search with terms of "monitoring or monitor or monitored", "grid", "computing resource"	9/6/2007	Jeong Park
Updated search, see notes	3/13/2008	Jeong Park

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner